

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/820,575
Filing Date April 7, 2004
Inventor Scott E. Moore et al.
Assignee Micron Technology, Inc.
Group Art Unit 1734
Examiner Unknown
Attorney's Docket No. MI22-2493
Title: Semiconductor Workpiece Processing Methods and Turbidity Monitoring Methods

Assistant Commissioner for Patents
P.O. Box 1450
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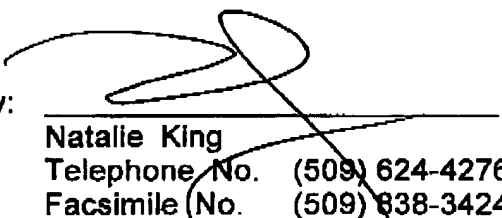
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TRANSMITTAL FORM (to be used for all correspondence after initial filing)	Application Number	10/820,575
	Filing Date	April 7, 2004
	First Named Inventor	Moore et al.
	Art Unit	1734
	Examiner Name	Unknown
Total Number of Pages In This Submission	Attorney Docket Number	MI22-2493

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SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT		
Firm or Individual	James D. Shaurette, Reg. No. 39,833 Wells SL John, P.S.	
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SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References – See Attached Form PTO-1449

The attached form PTO-1449 is submitted in compliance with 37 CFR §1.56. No admission is made regarding whether all the submitted references are prior art.

Respectfully submitted,

Dated: 4/12/05

By: 
James D. Shaurette
Reg. No. 39,833

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE			ATTY. DOCKET NO. M122-2493		SERIAL NO. 10820,575	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)					APPLICANT Scott E. Moore et al.			
					FILING DATE April 7, 2004		GROUP 1734	
U.S. PATENT DOCUMENTS								
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
	AA	6,096,185	8/1/2000	Corlett et al.				
	AB	5,791,970	8/11/1998	Yueh				
	AC							
	AD							
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FOREIGN PATENT DOCUMENTS								
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